

Electronic Acknowledgement Receipt

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Application Number:	10510695
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Title of Invention:	METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON SINGLE CRYSTAL AND SILICON WAFER
First Named Inventor:	Izumi Fusegawa
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Response to Election / Restriction Filed	121356RestrictionReq5-17-06.pdf	58621	no	2

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